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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/526,896
				Filing Date	10/29/2003
Date Submitted: July 6, 2007				First Named Inventor	Katsuya HASEGAWA
				Art Unit	1775
(use as many sheets as necessary)				Examiner Name	Aaron Austin
				Attorney Docket Number	017700-0173
Sheet	1	of	1		

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

UNPUBLISHED U.S. PATENT APPLICATION DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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/AA/	A1	English Translation of Preparation of SmBaCu3O2 Films with Improved In-Plane Alignment by Pulsed Laser Deposition; J. Japan Inst. Metals. Vol. 66, No. 4 (2002) pp 320-328.	

Examiner Signature	/Aaron Austin/	Date Considered	09/16/2007
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